

Nano-Photonic Crystal Waveguides for Ultra-Compact Tunable True Time Delay Lines

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ABSTRACT

Nanophotonics including photonic crystals promises to have a revolutionary impact on the landscape of photonics technology. Photonic crystal line defect waveguides show high group velocity dispersion and slow photon effect near transmission band edge. By using photonic crystal waveguides to build true time delay based phased array antenna or other optical signal processing systems, the length of the tunable true time delay lines can be dramatically reduced inversely proportional to group velocity dispersion in dispersion enhanced system architecture or reduced inversely proportional to group index in slow photon enhanced system architecture. The group index of the fabricated silicon photonic crystal line defect waveguide is experimentally demonstrated as high as 40 at optical wavelength around 1569 nm. The group velocity dispersion of the fabricated silicon photonic crystal line defect waveguide is as high as 50 ps/nm·mm at wavelength around 1569 nm, which is more than 10^7 times the dispersion of the standard telecom fiber ($D = 3$ ps/nm·km). Due to the integration nature of photonic crystals, system-on-chip integration of the true time delay modules can be easily achieved.

Keywords: Photonic crystal waveguide, phased array antenna (PAA), optical true time delay (TTD), group velocity dispersion (GVD), slow photon, wavelength tuning

I. INTRODUCTION

Phased array antennas (PAAs) have the advantages of high directivity and quick beam steering without physical movement. Each antenna element of a PAA must have the correct phase condition to accomplish the desired beam steering, as shown in Fig. 1. However, the conventional electrical phase trimmer technique is intrinsically narrow-band and introduces beam squint, which means that the radiating beam changes direction when the microwave frequency changes. Recently, there has been growing interest in optical true time delay (TTD) techniques with the features of wide bandwidth, compact size, reduced system weight, and low electromagnetic interference when compared with electrical TTD techniques [1-2]. The optical TTD techniques can be used not only in PAA systems, but also in other optical signal processing systems [3-4]. However, most of the optical TTD techniques require a large number of precisely time-delay matched optical elements such as lasers and optical delay segments resulting in a complex system design. Esman et al proposed a fiber-optic TTD technique using conventional dispersion compensating fiber ($D = -100$ ps/nm·km) to meet these requirements [2]. However, its dispersion parameter D is fairly small, thus long fibers are still needed in the TTD module to get the required time delay. Jiang et al recently demonstrated a dispersion enhanced wavelength tunable TTD technique for an X-band phased array antenna using dispersion enhanced photonic

II. DESIGN OF PHOTONIC CRYSTAL WAVEGUIDES

We use a W-1 line defect PhC waveguide design to achieve high group velocity dispersion or slow photon effect (high group index). The W-1 line defect photonic crystal waveguide can be easily generated by removing a single line defect from pure 2-D photonic crystal slab, as shown in Fig. 2. The slab is generated on a silicon-on-insulator wafer. The thickness of the silicon core layer is $t = 220 \text{ nm}$. Top cladding is air and bottom cladding is buried oxide layer with thickness of $2 \mu\text{m}$. The pitch size of the PhC is $a = 400 \text{ nm}$. The normalized air hole diameter is $d/a = 0.55$. The dispersion diagram of PhC waveguides can be calculated using the 3-D full vectorial plane-wave expansion (PWE) method, which is fast and accurate compared to other methods [20]. Since our PhC waveguide design is a 2-D PhC slab with line defects, we need to use a supercell having a size of $N \times M \times L$ instead of a natural unit cell to implement the periodic boundary conditions. As shown in Fig. 2 a $7 \times 1 \times 5$ supercell is used for simulation purposes. The simulated electrical and magnetic field intensities, $|E|^2$ and $|H|^2$, are also shown in Fig. 2. It shows that most of energy is guided around the defect inside the supercell. More simulation is done on the PhC waveguide. We can clearly see that the guided mode around the line defects, as shown in Fig. 3. We should notice here that normalized by the maximum intensity of the guided mode at the vertical center of the silicon slab waveguide at $Y = 0$, the maximum intensity at $Y = 54.8 \text{ nm}$ is less than that at $Y = -54.8 \text{ nm}$. The reason is that the guided mode decays faster in the top air layer than in the bottom buried oxide layer.

The dispersion parameter, $\omega(k)$, of PhC waveguide described above is also shown in Fig. 4(a). The bandgap is located between normalized frequencies $a/\lambda = 0.245 \sim 0.300$. The guided mode in the bandgap generated by introducing line defect is clearly shown here. The derived group index versus free-space optical wavelength is shown in Fig. 4(b). The large group index $n_g = 60$ is obtained around 1546 nm in this structure. The group index changes rapidly around the transmission band edge, which means high group velocity dispersion. The reason behind is due to the unusual flat of the guided mode around the transmission band edge in the dispersion diagram which leads to small group velocity thus high group index and large group velocity dispersion.

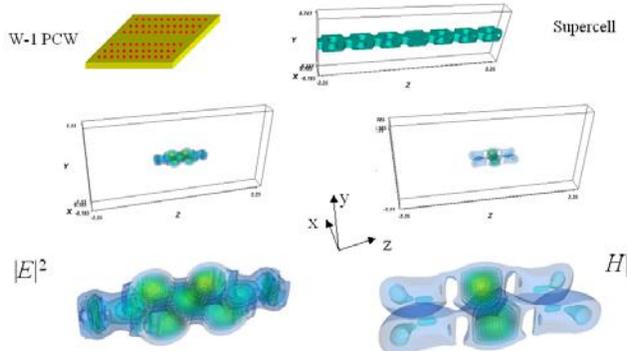


Fig. 2. Photonic crystal waveguide W-1 line defect schematic diagram, supercell used in simulation by 3-D full vectorial plane wave expansion method and electrical and magnetic field intensity from the simulation.

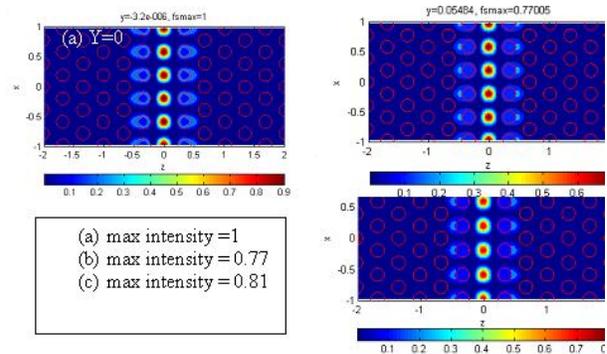


Fig. 3. Simulation of guided mode by 3-D full vectorial plane wave expansion method.

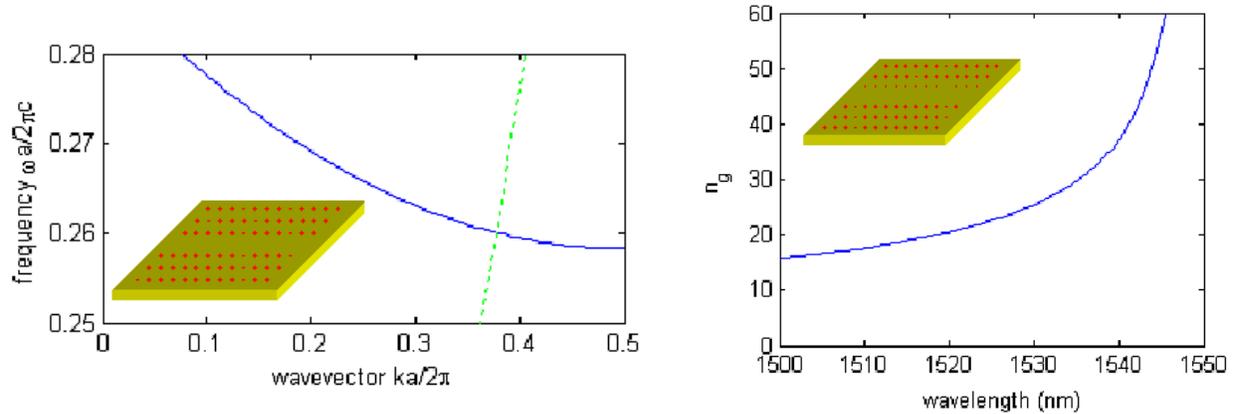


Fig. 4. (a) Dispersion diagram of a W-1 line defect photonic crystal slab waveguide by 3-D full vectorial plane wave expansion method. (b) Derived group index versus wavelength from dispersion diagram. High group index and large group velocity dispersion are clearly shown near transmission band edge at 1546 nm.

III. FABRICATION OF PHOTONIC CRYSTAL WAVEGUIDES

We fabricated photonic crystal waveguides (PCW) with silicon-on-insulator (SOI) based hexagonal periodic air-hole structures. We typically start with wet growing about 60 nm oxide at 850°C on top of a 6" SOI wafer. Then we cut it into about 1 cm × 1 cm square pieces. First PhC structures are patterned with E-beam resist ZEP-520A by E-beam nano-lithography (JEOL JBX-6000FS/E, resolution: 20 nm). After resist developing, the patterns are transferred to 60 nm oxide mask layer by CHF₃ chemistry in RIE. Then the E-beam resist residue is removed by plasma ashing in O₂. Finally the patterns are transferred to silicon core layer with oxide as the mask layer by HBr and Cl₂ chemistry in RIE. On each chip, devices with lattice constant $a = 400$ nm, air hole diameter $d = 220$ nm, and slab thickness $t = 220$ nm are fabricated. Post-etching oxidation at 850° is implemented for about 1 minute. The post-etching oxidation forms an additional 6~7nm oxide layer, with a surface significantly smoother than the original silicon surface after the dry etching. The air holes of the silicon photonic crystals expand noticeably after the completing the entire fabrication sequence. E-beam resist exposure and development, dry-etching of the oxide hard mask and the SOI layer all incur certain amount of expansion of the holes. Dry-etching SOI layer appears to be the most critical step in hole size control. We have optimized the process parameters and have introduced a proper pre-offset of the hole size in e-beam pattern design so that the hole size can be controlled with an accuracy of 5%.

IV. CHARACTERIZATION OF PHOTONIC CRYSTAL WAVEGUIDES

1. Morphological examination

The nano-structures of silicon photonic crystal waveguide have been imaged by a FEI Strata DM235 SEM/FIB nano-characterization. A number of scanning electron microscopic (SEM) pictures are shown in Fig. 5(a), which demonstrates the high quality of the silicon nano-structures fabricated through our optimized processes. For reference, we show in Fig. 5(b) an early fabrication result where the post-etching oxidation was not employed. In addition, we have

also used the focus ion beam (FIB) to polish the end-face of silicon rib waveguides. The resultant smooth end-face, as illustrated in Fig. 5(c) helps reduce the coupling loss between the silicon rib waveguide and the input fiber.

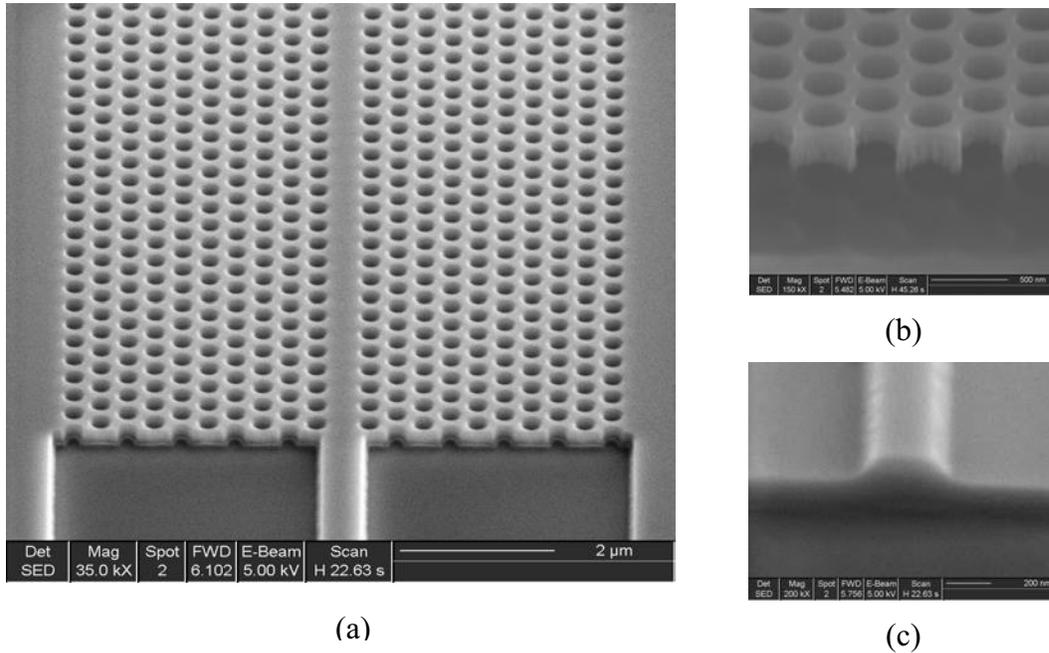


Fig. 5 SEM pictures of the nano-structures of silicon photonic crystal waveguides. (a) PCW fabricated *with post-etching oxidation*. The waveguide is based on a triangular lattice with lattice constant $a=400\text{nm}$, hole diameter $d=210\text{nm}$, and SOI thickness $t=215\text{nm}$. (b) Photonic crystal sidewall profile when the post-etching oxidation is NOT performed. The surface roughness is evident. (c) The silicon rib waveguide end-face polished by focus ion beam (FIB); highly smooth surface facilitates coupling.

2. Measurement of optical transmission

We also accurately characterize the optical transmission and dispersion of photonic crystal waveguide modes. A simplistic approach places a PhC waveguide between two straight silicon rib waveguides. However, the stray light—light reaching the output through the air above the chip surface—in the forward direction is often strong enough to smear the signal transmitted via the rib-PCW-rib guided channel. To overcome this problem, we introduced a waveguide bend [21], which shifts the output fiber by at least $600\mu\text{m}$ and significantly suppresses the stray light collected by the output fiber. The measurement illustrated in Fig. 6 is performed on a fully automated Newport Photonics Alignment/Packaging Station. Two lensed fibers are manipulated by two automated 5-axis stages, which are controlled by a computer to precisely align the fibers with the rib waveguides. Figure 7(a) shows a typical transmission spectrum of PhC waveguide with length $100a$, which is normalized by the spectrum of a silicon rib waveguide (with the same bend and length). Below 1560nm , a guided mode is present in the gap. The bulge in the longer wavelength part of the spectrum is attributed to the lower band of the photonic crystal.

A 40 μm -long PCW has typical loss of $6.5\pm 2\text{dB}$, while a 320 μm -long PCW has typical loss of $8.3\pm 3\text{dB}$. From these, one can estimate the propagation loss is fairly low, about 6.4dB/mm. The coupling loss at each interface between a PCW and a Si rib waveguide is about 3.1dB. Note that the waveguides fabricated without post-etching oxidation [Fig. 5(b)] typically have propagation losses over 20dB/mm, which manifests the advantage of oxidation.

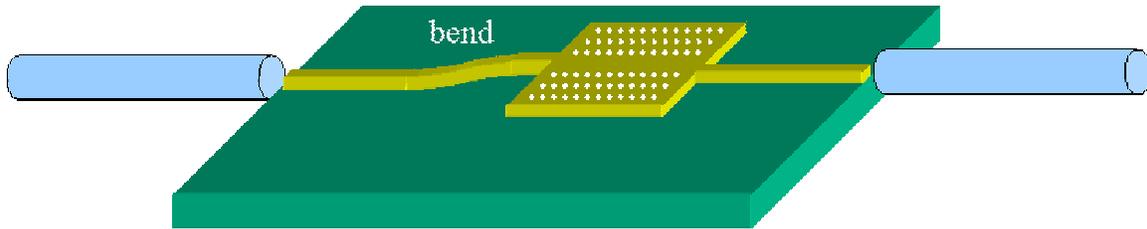


Fig. 6. Test setup for measuring the optical transmission of a photonic crystal waveguide. Two lensed fibers are used for better mode matching. A waveguide bend is used to shunt the relatively intense stray light in the forward direction.

3. Group index and group velocity dispersion calculation

The group index $n_g = c/v_g$ is calculated *directly* from the varying Fabry-Perot oscillation period of transmission spectrum [10], which incurs high uncertainty and fluctuation of computed n_g values due to noise and finite wavelength resolution of the spectrum. Similar problems occur in analyzing signals such digitized human voice, and the countermeasures are well established. Here we introduced a simple Windowed Fourier Transform (WFT) algorithm [22], which computes n_g from experimental transmission spectra with low fluctuation. Figure 7(b) attests the high n_g as anticipated, which promises over 10 times reduction in delay line length. The group velocity dispersion is also calculated as 50 ps/nm \cdot mm at 1569 nm. The dispersion is increased by 10^7 times compared to standard telecom LEAF fiber that has a dispersion parameter of 3 ps/nm \cdot km.

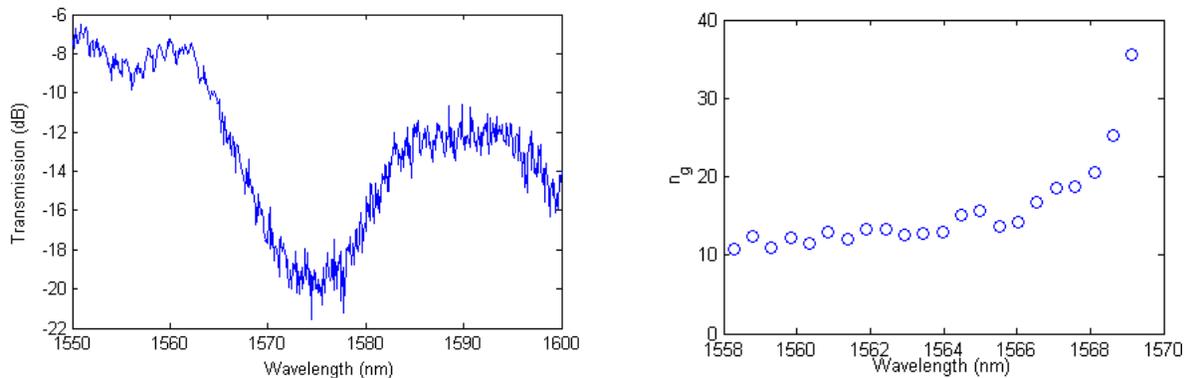


Fig. 7 (a) Transmission spectrum for a PCW with length $100a = 40\mu\text{m}$, normalized by the spectrum of a Si rib waveguide. (b) Group index n_g for a PCW, salient increases of n_g is evident..

V. TTD BASED ON PHC WAVEGUIDES

Line defect photonic crystal waveguides show high group velocity dispersion and slow photon effect as shown above. We proposed two TTD system architectures using the fabricated highly dispersive PhC waveguide delay lines mentioned above. These are *dispersion enhanced wavelength tunable TTD architecture* and *slow photon enhanced reconfigurable TTD architecture*. By using photonic crystal waveguide to build true time delay based phased array antenna, the TTD payload can be reduced inversely proportional to group velocity dispersion in dispersion enhanced system architecture or inversely proportional to group index in slow photon enhanced system architecture.

1. Dispersion enhanced wavelength tunable TTD architecture

In dispersion enhanced wavelength tunable TTD architecture, the lengths of the highly dispersive PhC waveguides are $L, L^*(n-1)/n, L^*(n-2)/n, \dots, L^*2/n, L/n,$ and 0 , as shown in Fig. 8(a). These PhC waveguides are connected to non-dispersive waveguide with lengths $0, L/n, L^*2/n, \dots, L^*(n-2)/n, L^*(n-1)/n, L,$ respectively. This would make the total length of each delay line L . Each delay line has the same nominal group delay at the central tuning wavelength λ_0 but with slightly different net dispersion by slight trimming the lengths of the non-dispersive waveguide or the connected optical fiber. The relative delay of the signals among the delay lines can thus be changed by tuning the optical wavelength. At the central tuning wavelength λ_0 , all the time delays are matched by trimming the non-dispersive waveguide. Thus, at λ_0 the main antenna beam will be directed broadside. At wavelengths deviating from λ_0 , each of the delay lines generates a time delay proportional to its dispersion parameter, D , and the highly dispersive PhC waveguide length, resulting in a phase change to steer the main antenna radiation beam. [2]

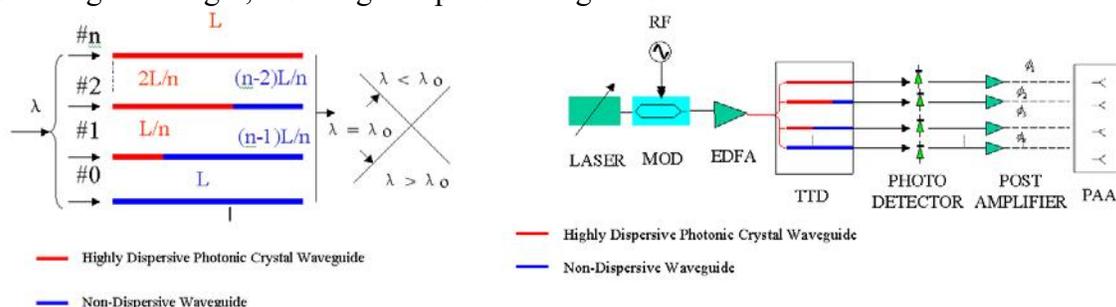


Fig. 8. (a) Dispersion enhanced wavelength tunable true time delay architecture. (b) Dispersion enhanced wavelength tunable true time delay for phased array antenna system setup.

A proposed 1-D system diagram using the proposed dispersion enhanced wavelength tunable TTD architecture is shown in Fig. 8(b), which is similar to the work demonstrated by Jiang et al [5]. An N -element 1-D X-band PAA system is proposed. A microwave signal is generated from the HP network analyzer 8510C [5]. The optical carrier from a tunable laser (tuning range: 1520-1580nm, spectral width: 200MHz, tuning resolution: $<0.024\text{nm}$) is modulated by a 10Gb/s LiNiO_3 modulator, optically amplified by an erbium doped fiber amplifier (EDFA), then distributed into the N sub-units of the TTD delay lines by a one-to- N fiber splitter. After the pre-determined time delay, the optical signals with correct phase relationships are detected by InGaAs high-speed photodiodes (bandwidth: 18 GHz) and individually fed into N antenna

elements after electrical amplification. The microwave radiations signals are detected by a microwave receiving horn connected to microwave spectra analyzer (MSA). The computer controlled rotational stage under the antenna head can rotate the antenna to measure the antenna radiation far field pattern. We also need to mention that the ultimate application of this approach is also limited by the tuning speed of the tunable laser. Wipiejewski et al reports a tunable laser with 40ns tuning speed, which is fast enough for most PAA applications [23].

2. Slow photon enhanced reconfigurable TTD architecture

We also proposed a monolithic slow photon enhanced reconfigurable TTD architecture. Reconfigurability of the time delay was built into the structure by combining the PhC waveguides and optical switch [24], as shown in Fig. 9. The optical switch can also be implemented with a PhC approach in the near future [25]. The inclusion of optical switches is critical for application where power-consumption is a sensitive issue. Another advantage of using optical switch is the establishment of the scaling architecture with a minimum number of hardware devices. For example, we can achieve $2^N = 512$ time delays with $N=9$ segment waveguide. The differential time delay through one reconfigurable time delay line τ is proportional to the length and group index. By increasing the group index, the PhC delay line length can be reduced proportionally. Due to the integration of PhC integration, optical integrated circuits can be implemented for this structure.

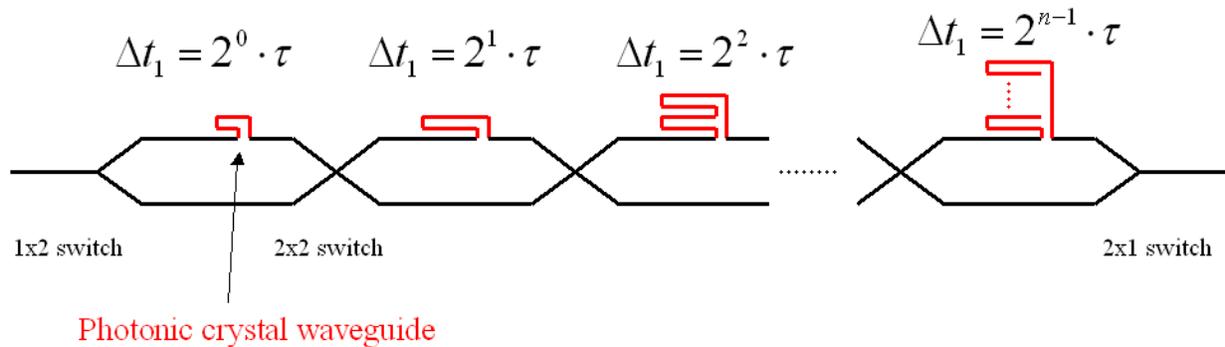


Fig. 9. Slow photon enhanced reconfigurable true time delay architecture.

VI. CONCLUSION

Photonic crystal line defect waveguides show high group velocity dispersion and slow photon effect near transmission band edge. By using photonic crystal waveguides to build true time delay based phased array, the length of the tunable true time delay lines can be dramatically reduced inversely proportional to group velocity dispersion in dispersion enhanced system architecture or reduced inversely proportional to group index in slow photon enhanced system architecture. The group index of the fabricated silicon photonic crystal line defect waveguide is experimentally demonstrated as high as 40 at optical wavelength around 1569 nm. The group velocity dispersion of the fabricated silicon photonic crystal line defect waveguide is as high as 50 ps/nm·mm at wavelength around 1569 nm, which is more than 10^7 times the dispersion of the standard telecom fiber ($D = 3$ ps/nm·km). Due to the integration nature of photonic crystals, system-on-chip ultra-compact integration of the true time delay modules can be easily achieved.

The system demonstration of highly dispersive silicon photonic crystal waveguides based true time delay for phased array antenna is on going now and will be presented in the near future.

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